

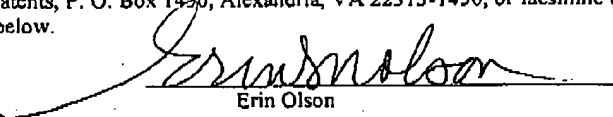
MAR 28 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Eric Bornstein
Application Serial No.: 10/649,910
Filing Date: 26 August 2003
Title: NEAR INFRARED MICROBIAL ELIMINATION LASER SYSTEM
Examiner: Shay, David M.
Art Unit: 3735
Atty. Docket No.: 072287-0019
Confirmation No.: 5770

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted (571-273-8300) to the USPTO, on the date indicated below.

Date: 3/28/07
Erin Olson

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT - ELECTION WITH TRAVERSE

This paper is in response to the Office Action dated 29 December 2006, with included restriction requirement, for the above-identified application.

The Applicant requests that subject application be amended in accordance with the following:

- **Amendments to the Claims**, as listed in the listing of claims beginning on page 2 of this paper; and
- **Remarks**, beginning on page 6 of this paper.

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